

Docket No.: 1794-0141P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Yoshinobu AOYAGI et al.

Application No.: 09/941,612

Confirmation No.: 6758

Filed: August 30, 2001

Art Unit: 1722

For: IMPURITY DOPING METHOD FOR  
SEMICONDUCTOR AS WELL AS SYSTEM  
THEREFOR AND SEMICONDUCTOR  
MATERIALS PREPARED THEREBY

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Examiner: M. J. Song

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Decision on Appeal dated April 27, 2007, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.